

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2812**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masatake NAKANO

Group Art Unit: 2812

Application No.: 10/500,381

Examiner: S. ISAAC

Filed: June 29, 2004

Docket No.: 120164

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 13, 2006 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**